



Inventor: Gurtej S. Sandhu, et al.

Title: Deposition Methods and Apparatuses Providing Surface Activation

Assignee: Micron Technology, Inc.

Serial No.: 09/652,533

Filing Date: August 31, 2000

Docket No. MI22-1385


**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether any of the submitted references is prior art. Copies of the references are attached.

Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: 17 Jul 2003

Attorney:   
James E. Lake  
Reg. No. 44,854

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09/652,533LIST OF ART CITED BY APPLICANT  
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APPLICANT Gurtej S. Sandhu

FILING DATE  
August 31, 2000GROUP  
2812

## U.S. PATENT DOCUMENTS

| *Examiner Initial |    | Document Number | Date    | Name         | Class | Subclass | Filing Date If Appropriate |
|-------------------|----|-----------------|---------|--------------|-------|----------|----------------------------|
|                   | AA | 5,985,770       | 11/1999 | Sandhu et al |       |          |                            |
|                   | AB | 5,281,274       | 1/1994  | Yoder        |       |          |                            |
|                   | AC | 5,366,555       | 11/1994 | Kelly        |       |          |                            |
|                   | AD | 5,413,671       | 5/1995  | Ketchum      |       |          |                            |
|                   | AE | 5,747,113       | 5/1998  | Tsai         |       |          |                            |
|                   | AF | 6,306,216       | 10/2001 | Kim et al    |       |          |                            |
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|                   | AH |                 |         |              |       |          |                            |
|                   | AI |                 |         |              |       |          |                            |
|                   | AJ |                 |         |              |       |          |                            |
|                   | AK |                 |         |              |       |          |                            |
|                   | AL |                 |         |              |       |          |                            |

## FOREIGN PATENT DOCUMENTS

|  |    | Document Number | Date | Country | Class | Subclasses | Translation |    |
|--|----|-----------------|------|---------|-------|------------|-------------|----|
|  |    |                 |      |         |       |            | Yes         | No |
|  | AM |                 |      |         |       |            |             |    |
|  | AN |                 |      |         |       |            |             |    |

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

|  |    |  |  |
|--|----|--|--|
|  | AO |  |  |
|  | AP |  |  |
|  | AQ |  |  |
|  | AR |  |  |

EXAMINER

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